

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant: | Werner Ertle et al. | Examiner: | Robert T. Huber |
| Serial No.: | 10/522,502 | Group Art Unit: | 4146 |
| Filed: | November 11, 2005 | Docket No.: | I431.124.101/FIN404PCT/US |
| Title: | SEMICONDUCTOR WAFER WITH ELECTRICALLY CONNECTED CONTACT AND TEST AREAS | | |

AMENDMENT AND RESPONSE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment and Response is in reply to the Non-Final Office Action mailed February 24, 2010. Please amend the above-identified patent application as follows: